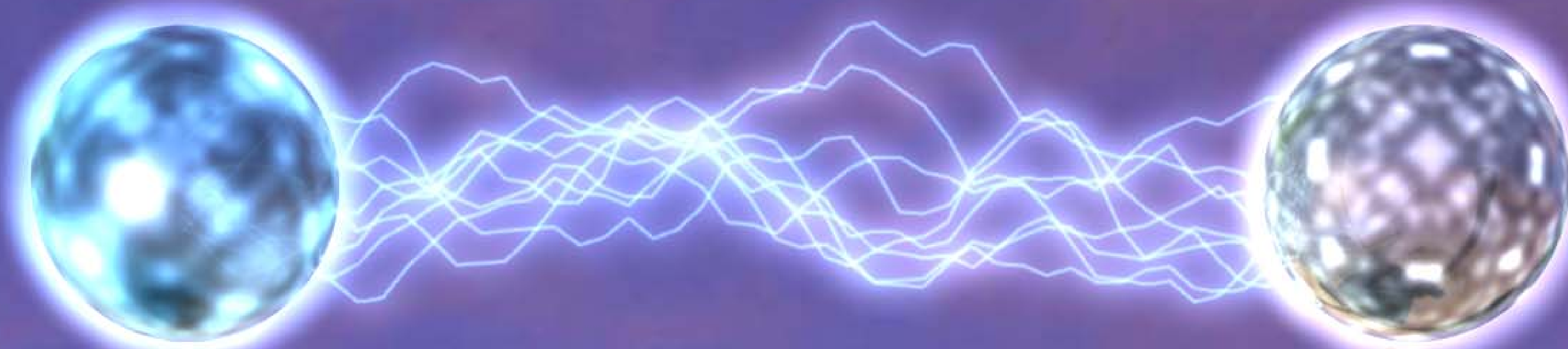# NSS6

6th International Workshop on Nano-Scale Spectroscopy & Nanotechnology
October 25-29, 2010. Kobe Univ., Kobe JAPAN

Scope

Progress in nanofabrication technology has led to the development of semiconductor nano-structures with characteristic physical properties and potential applications in micro and optoelectronic devices. The international Workshop on Nanoscale Spectroscopy and Nanotechnology is a biannual meeting series to share the information on latest research advances of science and technology in the nanometer regime. The scope includes electronic, optical, magnetic, mechanical and transport properties of nanoscale systems, nanoscale devices and nanomanipulation.

NSS6 provides a forum for the exchange of recent scientific and technical knowledge in this rapidly growing field.

Important Dates

Call for Papers:	April 1, 2010
Abstract Submission Deadline:	July 16, 2010
Preliminary Program:	Aug. 20, 2010
Early Registration Deadline:	Aug. 31, 2010
Proceedings Submission Deadline:	Oct. 29, 2010

Conference organization

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